

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q85660

Heiji WATANABE, et al.

Appln. No.: 10/521,311

Confirmation No.: 1690

Group Art Unit: 2815

Filed: January 14, 2005

Examiner: WARREN, MATTHEW E

For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND  
MANUFACTURING APPARATUS OF THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 1, 2008, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS.....	2
REMARKS.....	22